



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application

Inventor(s): Jeffrey W. Carr

Application No.: 10/002,035

Confirm. No.: 5043

Filed: November 7, 2002

Title: APPARATUS AND METHOD FOR
ATMOSPHERIC PRESSURE REACTIVE
ATOM PLASMA PROCESSING FOR
SHAPING OF DAMAGE FREE SURFACES

PATENT APPLICATION

Art Unit: 1703

Examiner: Unknown *Olson*

Customer No. 23910

1763

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Signature Date: April 26, 2002

(Attorney Signature)

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Sir:

TC 1700

Enclosed are 10 sheets of formal drawings for the above-identified patent application.

Subject to the Examiner's approval, please substitute the enclosed drawings for the drawings previously submitted.

Respectfully submitted,

Date: 4/26/02

By: *Jason D. Lohr*

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